



Docket No.: 4794-0101P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Katsunori NAGATA et al.

Application No.: 10/828,305

Confirmation No.: 4808

Filed: April 21, 2004

Art Unit: 1734

For: METHOD AND APPARATUS FOR STICKING
POLARIZER TO SUBSTRATE

Examiner: J. D. Sells

REPLY UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OK to Enter
DS 3/7/06

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 29, 2005, finally rejecting claims 1, 3, 4, and 6-8, this is a Reply limited to a reconsideration of the rejection:

Remarks/Arguments begin on page 2 of this paper.